Initial Information Data Sheet

Inventor Information

Inventor One Given Name:

Family Name:

Postal Address Line One

Postal Address Line Two

City:

State or Province: Postal or Zip Code: Citizenship Country:

Inventor Two Given Name:

Family Name:

Postal Address Line One

Postal Address Line Two

City:

State or Province:
Postal or Zip Code:
Citizenship Country:

Mitsuyuki ASAKI

c/o ADVANTEST CORPORATION

1-32-1 Asahi-cho, Nerima-ku

Tokyo Japan 179-0071

Japan

Akira

KINTAKA

c/o ADVANTEST CORPORATION

1-32-1 Asahi-cho, Nerima-ku

Tokyo Japan 179-0071 Japan

Correspondence Information

Name Line One:

Name Line Two:

Address Line One:

Address Line Two:

City:

State or Province:

Postal or Zip Code:

Telephone:

Fax:

Electronic Mail:

David L. Fehrman

Morrison & Foerster LLP

555 W. 5th Street

35th Floor Los Angeles California 90013

213-892-5601 213-892-5454

DFehrman@mofo.com

Application Information

Title Line One: PATTERN WIDTH MEASURING APPARATUS, PATTERN WIDTH

Title Line Three: MEASURING METHOD, AND ELECTRON

Title Line Four: BEAM EXPOSURE APPARATUS

Total Drawing Sheets: 6
Formal Drawings?: Yes

Application Type: Non-provisional Docket Number: 514802002600

Representative Information

Representative Customer Number: 25224

Continuity Information

This application:
> Application One:
Filing Date:

which is a:

>>Application Two:

Filing Date:

Prior Foreign Applications

Foreign Application One: 2002-293717 Filing Date: October 7, 2002

Country: Japan Priority Claimed: Yes

Assignee Information

Assignee One: ADVANTEST CORPORATION Postal Address Line One 1-32-1 Asahi-cho, Nerima-ku

Postal Address Line Two

City: Tokyo
State or Province: Japan
Postal or Zip Code: 179-0071